

03500.014529.1

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
	:	Prior Examiner: C. L. Novacek
Yukiko IWASAKI, et al.)	
	:	Prior Group Art Unit: 2822
Application No.: Unassigned (Divisional)	
of Appln. No. 09/586,887,	:	
filed June 5, 2000))	
	:	
Filed: September 24, 2003)	
(filed concurrently herewith)	:	
)	
For: PROCESS FOR PRODUCING	:	September 24, 2003
SEMICONDUCTOR MEMBER,)	
PROCESS FOR PRODUCING	:	
SOLAR CELL, AND ANODIZING)	
APPARATUS	:	

Mail Stop Patent Application
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. §1.56 and in accordance with the practice under 37 C.F.R. §§1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449.

U.S. Application Nos. 08/999,132, 09/046,433, 09/047,327, 09/047,326, 09/046,600, 09/219,748, 09/310,954, 09/312,843, 09/401,775 and 09/047,325, which were

cited in parent Application No. 09/586,887, issued as U.S. Patent Nos. 6,190,937, 6,221,738, 6,382,292, 6,143,628, 6,258,698, 6,306,729, 6,331,208, 6,613,678, 6,391,743, 6,211,038, respectively. Copies of these U.S. patents are not enclosed, since the Patent Office has waived the requirement under 37 C.F.R. §1.98(a)(2)(I) for submitting a copy of each cited U.S. patent for applications filed after June 30, 2003.

All of the remaining documents listed on the Form PTO-1449 were cited in parent Application No. 09/586,887. The Examiner is respectfully directed to the Patent and Trademark Office files for review of these documents. See MPEP §609.

The Examiner's attention is also directed to the following U.S. Application:

<u>Application No.</u>	<u>Filing Date</u>	<u>Group Art Unit</u>	<u>Inventor(s)</u>
09/047,338	March 25, 1998	2814	K. Ohmi T. Yonehara K. Sakaguchi

A copy of this U.S. Application was submitted in parent Application No. 09/586,887.

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned with the next communication from the Office, indicating that such information has been considered.

Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our below-listed address.

Respectfully submitted,

A handwritten signature in dark ink, appearing to read "Damond Vadnais", is written over a horizontal line.

Attorney for Applicants

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FORM PTO 1449 (modified) U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary)				ATTY DOCKET NO. 03500.014529.1		APPLICATION NO. Unassigned (Divisional of Appln. No. 09/586,887, filed June 5, 2000)	
Date Submitted: September 24, 2003				APPLICANT Yukiko IWASAKI ET AL.			
				FILING DATE September 24, 2003		PRIOR GROUP 2822	
U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
		5,856,229	01/1999	Sakaguchi, et al.			
		5,811,348	09/1998	Matsushita, et al.			
		6,190,937	02/2001	Nakagawa, et al.			
		6,221,738	04/2001	Sakaguchi, et al.			
		6,382,292	05/2002	Ohmi, et al.			
		6,143,628	11/2000	Sato, et al.			
		6,306,729	10/2001	Sakaguchi, et al.			
		6,331,208	12/2001	Nishida, et al.			
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
		8-213645	08/1996	Japan			abstract
		7-302889	11/1995	Japan			abstract
		10-190032	07/1998	Japan			abstract
		0840381	05/1998	Europe			
OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)							
		R.P. Holmstrom, et al., "Complete dielectric isolation by highly selective and self-stopping formation of oxidized porous silicon", Appl. Phys. Lett., vol. 42, no. 4, pp. 386-388 (1983).					
		Y. Nakagawa, et al., "Bulk-wave generation due to the nonlinear interaction of surface acoustic waves", J. Appl. Phys., vol. 49, no. 12, pp. 5924-5927 (1978).					
EXAMINER				DATE CONSIDERED			

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

FORM PTO 1449 (modified) U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary) Date Submitted: September 24, 2003				ATTY DOCKET NO. 03500.014529.1		APPLICATION NO. Unassigned (Divisional of Appln. No. 09/586,887, filed June 5, 2000)	
				APPLICANT Yukiko IWASAKI ET AL.			
				FILING DATE September 24, 2003		PRIOR GROUP 2822	

U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
	6,613,678	09/2003	Sakaguchi, et al.				
	6,391,743	05/2002	Iwane, et al.				
	6,211,038	04/2001	Nakagawa, et al.				
	6,428,620	08/2002	Yamagata, et al.				
	6,376,332	04/2002	Yanagita, et al.				
	5,565,084	10/1996	Lee, et al.				
	6,258,698	07/2001	Iwasaki, et al.				

FOREIGN PATENT DOCUMENTS							
DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT		
0989616	03/2000	Europe					
0793263	09/1997	Europe					

OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)		

EXAMINER	DATE CONSIDERED
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Sheet 2 of 2

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